

Sheet 1 of 1  
10/582343

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128275		<div style="font-size: 2em; font-weight: bold;">10/582343</div>	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICATION NO. PCT/FR2004/003216 Stage of PCT/FR2004/003216			
				APPLICANT Philippe ROBERT			
				FILING DATE June 9, 2006			

  

U.S. PATENT DOCUMENTS				
Examiner Initials	Cite No.	Document Number	Date	Name
	1	5,090,254	2/25/1992	GUCKEL et al.

  

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation
	2	DE 100 05 555 A	8/16/2001	GERMANY		
	3	EP 0 451 992 A	10/16/1991	EUROPE		

  

OTHER DOCUMENTS		
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)
	4	M. BARTEK et al., "Vacuum sealing of microcavities using metal evaporation," <u>Sensors and Actuators A</u> , vol. 60, no. 1-3, pp. 364-368 (May 1, 1997).
	5	M. FURTSCH et al., "Texture and stress profile in thick polysilicon films suitable for fabrication of microstructures," <u>Thin Solid Films</u> , vol. 296, no. 1-2, pp. 177-180 (March 1, 1997).

  

EXAMINER  /Kevin Parendo/	DATE CONSIDERED  03/06/2009
---------------------------------	-----------------------------------

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: June 9, 2006

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.P./